



N THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Toshiharu Furukawa et al. : Date: May 27, 2005

Group Art Unit: 2811 : IBM Corporation

Examiner: Steven Ho Yin Loke : Intellectual Property Law

Serial No.: 10/777,576 : Dept. 917, Bldg. 006-1

Filed: February 12, 2004 : 3605 Highway 52 North

Title: METHODS OF FABRICATING : Rochester, MN 55901

VERTICAL CARBON NANOTUBE FIELD EFFECT TRANSISTORS FOR ARRANGEMENT IN ARRAYS AND FIELD EFFECT TRANSISTORS AND

ARRAYS FORMED THEREBY

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Dear Sir:

CERTIFICATE OF MAILING UNDER 37 C.F.R. 1.8(a)

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on May 27, 2005.

James R. Nock, Senior Attorney

Debra A. Peterson

LETTER

Enclosed is a copy of our March 16, 2005 response to the Office Action dated March 11, 2005. Please note that the last two numbers of the serial number were transposed. Please purge this response from Serial Number 10/777,567 to this file, Serial Number 10/777,576.

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Respectfully submitted,

Telephone: (507) 253-4661

Fax No.: (507) 253-2382 Registration No.: 42,937

Docket No.: ROC920030271US1

Serial No.: 10/777,576

MAY 3 1 2005 Docket No.: Applicant(s): Furu Kawa Serial No.:____ The U.S. Patent Office acknowledges and have stamped hereon the date of receipt of moilems checked below which were mailed on MAR 2 1 2005 □Affidavit □Amendment □ Patent Application Papers - Transmittal □ Spec. & Abstract: ___ pages, incl. ___ claims □ Declaration □ Drawings: ___ sheets ☐ Assignment; Record. Cover Sheet (2 copies) □ Info. Discl. Stmt, PTO/SB/08A & Refs. □ Preliminary Amendment □ Notice of Appeal MAR 2 8 2005 □ Appeal Brief □ Petition □ Request for Extension of Time Response to Restriction Requiremen **[**3

If via Express Mail _(affix label here)__



THE WITTED STATES PATENT AND TRADEMARK OFFICE

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Merra

Debra A. Peterson

RESPONSE TO RESTRICTION REQUIREMENT

In response to the Office Action dated March 11, 2005, Applicants make the following election and remarks:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this Response.

Election to Restriction is made on page 6 of this Response.

Remarks begin of page 7 of this Response.

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